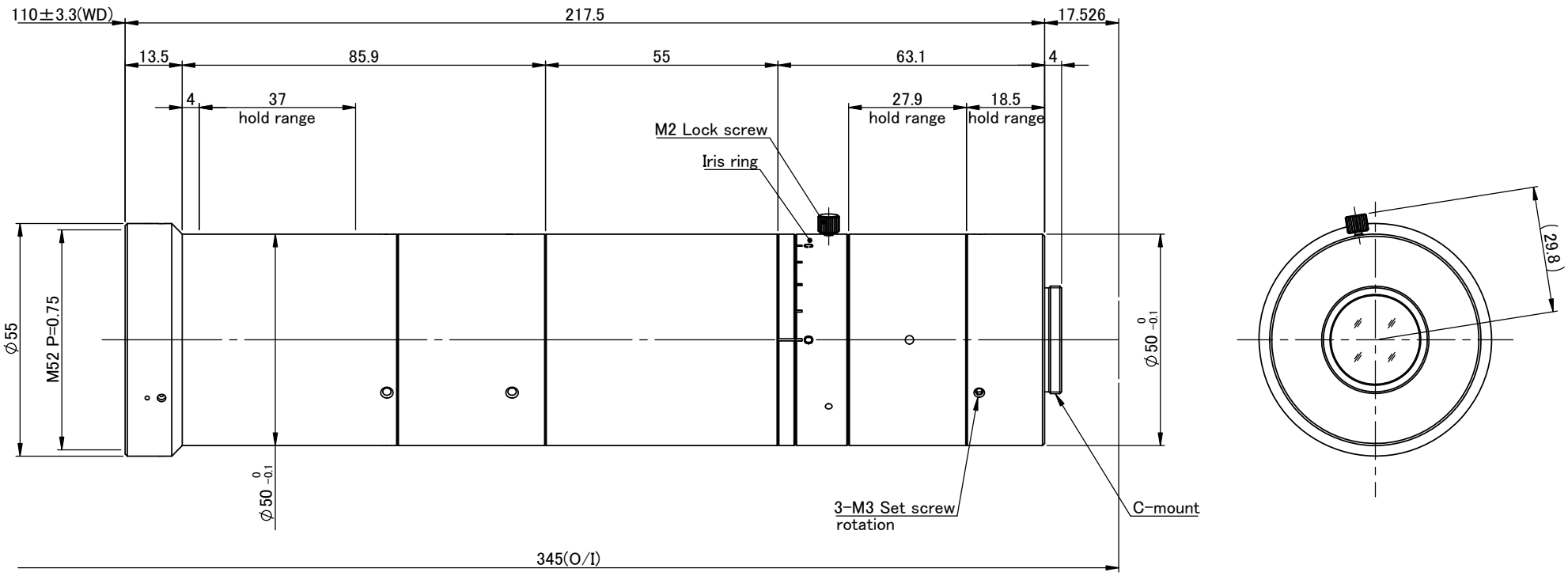
Confidential



TREATMENT 処理		–			MATERIAL	–	UNIT	METHOD			
					CHAMFER	–					
TREATMENT CONTACT 処理接点		–			FINISHING	–	mm				
					DECENTRATION	–					
APPROVED	CHECKED	DESIGNED	DRAWN	TOLERANCE	–	REMARK	VS-TCTV08-110/S				
鈴木(利)	鈴木(利)	松井	宮下	ANGLE	–	NAME	DRAWING				
				SCALE	1:1	DRAW NO.	M2105E-A00100				
				DATE	'25.01.31						

△×			
NO. ×	REVISION	DATE	NAME